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To: Commissioner for Patents
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From: Pamela J. Squyres
Attorney Docket: MA-027
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FAX NUMBER 703-872-9306

Re: Patent Application of: Michael A. Vyvoda et al.	Examiner: Anh D. Mai
Serial No.: 09/776,009	Group Art Unit: 2814
Filed: February 2, 2001	Attorney Docket No.: MA-027
Title: Wafer Surface that Facilitates Particle Removal	

Document(s) Transmitted:

- ☐ Amendment and Response to Non-Final Office Action (7 pages)

Total pages of this transmission, including the cover letter: 8
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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Vyvoda et al.	
Application No.: 09/776009	Group Art Unit: 2814
Filed: 02/02/2001	Examiner: Anh D. Mai
Title: Wafer Surface that Facilitates Particle Removal	
Attorney Docket No.: MA-027	

Assistant Commissioner for Patents
PO Box 1450
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October 12, 2004

To the Commissioner:

AMENDMENT AND RESPONSE TO NON-FINAL OFFICE ACTION

Please enter the following in response to the non-final Office Action of July 14, 2004, in the above-captioned application. A complete list of pending claims begins on page 2. Remarks begin on page 4. A Conclusion appears on page 7.

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